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**SUPPLEMENTAL INFORMATION
DISCLOSURE STATEMENT BY
APPLICANT**

(Use as many sheets as necessary)

Sheet 1 of 1

Complete if Known

Application Number	10/524,610
International Filing Date	August 11, 2005
First Named Inventor	Franz LAERMER
Art Unit	2818
Examiner Name	Hoang Quan Tran Ho
Attorney Docket Number	10191/4116

U.S. PATENT DOCUMENTS

Examiner Initials *	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number - Kind Code ² (if known)			

FOREIGN PATENT DOCUMENTS

Examiner Initials *	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
		Country Code ³ - Number ⁴ - Kind Code ⁵ (if known)				
		JP 7-106328	April 21, 1995			*
		JP 10-74755	March 17, 1998			*

* English language abstract provided.

NON PATENT LITERATURE DOCUMENTS

Examiner Initials *	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
		T. Homma, "Fluorinated interlayer dielectric films in ULSI multilevel interconnections", Journal of Non-Crystalline Solids, 1995, 187, pgs. 49-59	
		T. Homma, "Stability of a new polyimide siloxane film as interlayer dielectrics of ULSI multilevel interconnections", Thin Solid Films, November 25, 1993, Vol. 235, Issues 1-2, pages 80-85. Provided is abstract thereof.	
		T. Homma, "Electrical stability of polyimide siloxane films for interlayer dielectrics in multilevel interconnections", Thin Solid Films, 1999, Vol. 340, pgs. 237-241	
		Nguyen Nhu Toan, "Spin-on-glass materials and applications in advanced IC technologies", 1999, retrieved from the Internet, URL: http://doc.utwente.nl/1409/	

Examiner Signature	Date Considered
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. ¹ Applicant's unique citation designation number (optional). ² See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

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